

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF:

Lower

CASE:

OST-031107

**SERIAL NO.:** 

10/619,933

FILED ON:

July 15, 2003

FOR:

METHOD FOR MEASURING THE INTENSITY PROFILE OF AN

ELECTRON BEAM, IN PARTICLAR A BEAM OF AN ELECTRON-BEAM MACHINING DEVICE, AND/OR FOR MEASURING AN OPTICAL SYSTEM FOR AN ELECTRON BEAM AND/OR FOR ADJUSTING AN OPTICAL

SYSTEM FOR AN ELECTRON BEAM, MEASURING STRUCTURE FOR SUCH A METHOD AND ELECTRON-BEAM

**MACHINING DEVICE** 

**ATTENTION OF:** 

STATEMENT OF

**BASIS FOR** 

RELEVANCE OF FOREIGN

LANGUAGE

**DOCUMENTS** 

**IDENTIFIED IN** 

**SUBMITTED** 

**SUPPLEMENTAL** 

**INFORMATION** 

**DISCLOSURE** 

**STATEMENT** 

COMMISSIONER FOR PATENTS P.O. Box 1450

Alexandria, VA 22313-1450

**EXAMINER:** 

Dear Sir:

If any charges or fees must be paid in connection with the following communication, they may be paid out of our Deposit Account No. 50-0545.

**Publication Number** 

**Publication Date** 

**Basis for Relevance** 

DE 37 18 177 A1

December 15, 1988

Device for focusing an electron beam onto a workpiece consists of controlling the focusing current in direct relationship to the voltage measured from the electrons reflected back from the workpiece surface. Enables the burning point of the beam to be exactly focused onto the workpiece surface or to be focused at a constant point below or above the surface irrespective of the unevenness of the surface or of relative movement between beam and surface.

FACTOR & LAKE, LTD. 1327 W. Washington Blvd., Suite 5 G/H Chicago, IL 60607 (312) 226-1818 (312) 226-1919 (fax) Jody L. Factor Micheal D. Lake Jacob D. Koering 34157 33727 51890 De 101 29 019 A1

January 10, 2002

A metal mark portion made of tungsten has predetermined mark pattern. The metal mark portion is supported by a substrate, and has the line width of about 0.1 mu m or less. For adjusting the focus of electron beam and for measuring the shape of electron beam and for measuring the shape of electron beam in electron beam processing apparatus such as electron microscope, electron beam testing apparatus and electron beam length measurement apparatus. Accurately measures the shape of electron beam as line width is reduced. Reduces focus adjustment time.

Should anything further be required, a telephone call to the undersigned at (312) 226-1818 is respectfully invited.

Respectfully submitted,

Dated: \_\_\_2-24-04

Joseph L. Factor

One of Athorneys for Applicant

## **CERTIFICATE OF MAILING**

I hereby certify that this correspondence is being deposited with the United States Patent Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on \_Z -Z 4-0 4

Jody L. Factor

Name of Applicant, assignee, applicant's attorney or Registered Representative

Signature

PTO/SB/08A (06-03)

Approved for use through 07/31/2003. OMB 0651-0031

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Substitute for form 1449A/PTO INFORMATION DISCLOSURE STATEMENT BY APPLICANT

Complete if Known 10/619933 **Application Number** 7/15/2003 Filing Date First Named Inventor Lower Not yet assigned Art Unit Not yet assigned **Examiner Name** 

(use as many sheets as necessary)

OST-031107 Attorney Docket Number Sheet

U.S. PATENT DOCUMENTS									
Examiner Initials*	Cite No.1	Document Number  Number - Kind Code <sup>2 (if known)</sup>	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear				
		US-3,752,952	08-14-1973	Ruge et al.					
		US-3,409,799	11-05-1968	Kurzwell et al.					
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FOREIGN PATENT DOCUMENTS									
Examiner Initials*	Cite No.1	Foreign Patent Document  Country Code <sup>3</sup> - Number <sup>4</sup> - Kind Code <sup>5</sup> (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T⁵			
		DE 37 18 177 A1	12-15-1988	Schmidt					
		DE 101 29 019 A1	01-10-2002	Takakuwa					
		EP 0 242 993	10-26-1987	The Welding Institute					
		GB 2 132 390 A	07-04-1984	Tokyo Shibaura Denki		-			
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Examiner		Date	1
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\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. Applicant's unique citation designation number (optional). See Kinds Codes of USPTO Patent Documents at <a href="https://www.uspto.gov">www.uspto.gov</a> or MPEP 901.04. The reign of the Emperor must precede the serial number of the patent document. Nind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. Applicant is to place a check mark here if English language Translation is attached.

Translation is attached.

This collection of information is required by 37 CFR 1.97 and 1.98. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to take 2 hours to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, U.S. Department of Commerce, P.O. Box 1450, Alexandria, VA 22313-1450. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.